

PATENT 25611-000085/US

ME THE	IN THE U.S. PATE	IN THE U.S. PATENT AND TRADEMARK OFFICE			
APPLICANTS	: Heung-Kyu KWON	et al.	CONF. NO.:	7367	
SERIAL NO.:	09/464,322		GROUP:	2815	
FILED:	December 15, 1999		EXAMINER:	C. Chu	
FOR:	SEMICONDUCTOR THE SAME	CHIP PAG	CKAGE AND METHO	D OF FABRICATING	
DOCKET NO.	25611-000085/US				
	<u>ST</u>	ATUS INC	DUIRY		
Customer Servi Randolph Build 401 Dulany Str Alexandria, VA	ling eet			December 27, 2005	
Sir:					
Please	advise the undersigned as to the	he status of	the above-identified ap	plication as follows:	
the duplicate c	icate copy of the present State opy be marked appropriately undersigned as soon as possib	to indicate			
Please request.	call the undersigned, at 703-6	68-8000 if	there are any questions	with regard to the present	
		Respectfi	ılly submitted,		
		HARNES By John	A. Castellano, Reg. No.		
JAC/pw			P.O. Box 8910 Reston, VA 20195 (703) 668-8000		
	Awaiting Action from Patent	t Office Exa	aminer		
	Expected Date for Action is:		·		
	Awaiting Decision by Board	of Appeals	S.		
	Application allowed on	· ·	·		
	Abandoned per		_•		

Other ______